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APPLICATION NUMBER	FILING or 371(c) DATE	GRP ART UNIT	FIL FEE REC'D	ATTY.DOCKET.NO	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/578.683	05/09/2006	1756	450	05823.0283	5	3	1

CONFIRMATION NO. 3685

22852

22852 FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER

901 NEW YORK AVENUE, NW WASHINGTON, DC20001-4413

FILING RECEIPT

Date Mailed: 11/24/2006

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### Applicant(s)

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Power of Attorney: The patent practitioners associated with Customer Number 22852

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/KR04/01363 06/08/2004

Foreign Applications

REPUBLIC OF KOREA 10-2003-0082777 11/20/2003

If Required, Foreign Filing License Granted: 11/22/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is US10/578.683

Projected Publication Date: 03/01/2007

Non-Publication Request: No Early Publication Request: No

\*\* SMALL ENTITY \*\*

Fabrication method of extreme ultraviolet radiation mask mirror using atomic force microscope lithography

## **Preliminary Class**

430

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